

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/790,220	OKAZAKI ET AL.	
Examiner	Art Unit	
Richard H Kim	2871	

	SEARCHED				
Class	Subclass	Date.	Examiner		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
DATE	EXMR			
2/24/2006	RHK			
	DATE DATE			